## **Amendments to the Claims**

Please cancel claims 1-9, 13-18, and 23-25, and amend the claims as follows:

- 1.-9. (Canceled)
- 10. (Currently Amended) The processing chamber of claim 1, A substrate centering apparatus comprising:

a chamber body having a bottom;

<u>a vertically moveable substrate support disposed in the chamber body and having a first side adapted to support a substrate during processing;</u>

at least three elements movably coupled to the substrate support in a spacedapart relation proximate a perimeter of the substrate support, further comprising at least three biasing members adapted for biasing the at least three elements radially inward relative to the substrate support;

a first end of each element extending beyond the first side of the substrate support, the first end adapted to engage an edge of the substrate; and

a second end of each element positioned below a second side of the substrate support and adapted to engage the bottom of the chamber body when the substrate is in a lowered position.

- 11. (Original) The processing chamber of claim 10, wherein the at least three biasing members are torsion springs disposed around pins coupling the at least three elements to the substrate support.
- 12. (Withdrawn) The processing chamber of claim 10, wherein the at least three biasing members comprise at least one of a compression spring or solenoid.
- 13.-25. (Canceled)